



LABORATORY GROWN DIAMOND REPORT

May 13, 2026	
IGI Report Number	LG794675918
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	11.38 x 5.43 x 3.22 mm

GRADING RESULTS

Carat Weight	1.11 CARAT
Color Grade	D
Clarity Grade	FLAWLESS

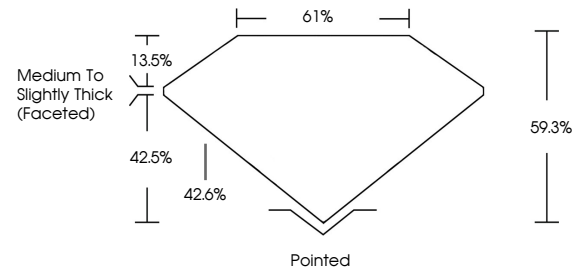
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG794675918

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG794675918
Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: Exceptional



Structured Light Environment Representation



COLOR

D E F G H I J Faint Very Light Light

CLARITY

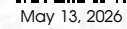
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



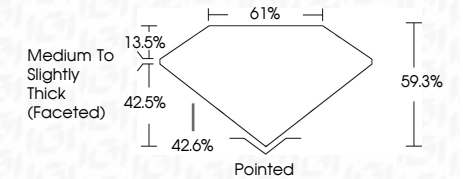
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May 13, 2026	IGI Report No LG794675918	1.11 CARAT	FLAWLESS	59.3%	Medium To Slightly Thick (Covered)	Pointed	NONE	1691 LG794675918
Marquise Brilliant	11.38 x 5.43 x 3.22 MM	Color Grade	Depth	Table		Symmetry	Fluorescence	
	Carat Weight	Clarity Grade	Girdle	Culet		Polish	Inscription(s)	

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Type I_c